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STATEMENT UNDER 37 CFR 3.73(b) Atty. Docket No. 1857.67800						
Applicant/Patent Owner: GURER et al.						
Application No./Patent No.: 6,955,720 Filed/Issue Date: October 18, 2005						
Entitled: Plasma Deposition of Spin Chucks to Reduce Contamination of Silicon Wafers						
ASML Holding N.V. , a corporation (Name of Assignee) (Type of Assignee, e.g., corporation, partnership, university, government agency, etc.)						
(Name of Assignee) (Type of Assignee, e.g., corporation, partnership, university, government agency, etc.)						
states that it is:						
1. X the assignee of the entire right, title, and interest; or						
an assignee of less than the entire right, title and interest						
(The extent (by percentage) of its ownership interest is%)						
in the patent application/patent identified above by virtue of either:						
A. An assignment from the inventor(s) of the patent application/patent identified above. The assignment was recorded in						
the United States Patent and Trademark Office at Reel, Frame, or for which a copy therefore is attached.						
OR						
B. X A chain of title from the inventor(s), of the patent application/patent identified above, to the current assignee as follows:						
1. From: GURER et al. To: Silicon Valley Group, Inc.						
The document was recorded in the United States Patent and Trademark Office at						
Reel <u>011882</u> , Frame <u>0042</u> , or for which a copy thereof is attached.						
2. From: Silicon Valley Group, Inc. To: ASML US, Inc.						
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3. From: SVG Lithography Systems, Inc. To: ASML US, LLC						
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$\overline{\mathrm{X}}$ Additional documents in the chain of title are listed on a supplemental sheet.						
As required by 37 CFR 3.73(b)(1)(i), the documentary evidence of the chain of title from the original owner to the assignee was, or concurrently is being, submitted for recordation pursuant to 37 CFR 3.11.						
[NOTE: A separate copy (i.e., a true copy of the original assignment document(s)) must be submitted to Assignment Division in accordance with 37 CFR Part 3, to record the assignment in the records of the USPTO. <u>See MPEP 302.08</u>]						
The undersigned (whose title is supplied below) is authorized to act on behalf of the assignee.						
December 9, 2008						
Signature Date						
(202) 271 2600						
Glenn J. Perry, Reg. No. 28,458 (202) 371-2600 Printed or Typed Name Telephone Number						
Authorized Agent Title						

This collection of information is required by 37 CFR 3.73(b). The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to take 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Statement Under 37 CFR 3.73(b) (PTO/SB/96) Supplemental Sheet for Chain of Title, Item B

Applicant/Owner: GURER et al.

Application No./Patent No.: 6,955,720						
Application Date/Issue Date: October 18, 2005						
Title: Plasma Deposition of Spin Chucks to Reduce Contamination of Silicon Wafers						
Name of Assignee: ASML Holding N.V.						
Type of Assignee: corporation						
Part B Continued: Additional Documents in the Chain of Title						
4.	From: ASML US, Inc. To: ASML US, LLC The document was recorded in the United States Patent and Trademark Office at					
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